

## Raman spectroscopy study of damages induced in polycrystalline Si<sub>3</sub>N<sub>4</sub> by swift heavy ion irradiation

In this work the Raman spectroscopy method was used to study the radiation damage and associated internal mechanical stresses in polycrystalline silicon nitride ( $Si_3N_4$ ).  $Si_3N_4$  samples have been irradiated with swift heavy Xe and Bi ions with energies of 167 and 710 MeV, respectively, in the range of fluences from  $1E11$  to  $4.87E13\text{ ions/cm}^2$ . The spectra of the cross-section of the irradiated region and the near-surface layer of the samples were registered at room temperature. The parameters of the FWHM -  $205\text{ cm}^{-1}$  and peak position -  $862\text{ cm}^{-1}$  were used to characterize the amorphization and mechanical stress level.

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